

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Anne E. Miller et al.

Examiner: Chen, Kin Chan

U.S. Serial No: 09/715,282

Art Unit: 1765

Filed: November 16, 2000

For: SLURRY AND METHOD FOR CHEMICAL
MECHANICAL POLISHING OF COPPER

Commissioner of
Patents and Trademarks
Washington, D.C. 20231

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RESPONSE TO ELECTION REQUIREMENT

Sir:

In response to the Election Requirement mailed June 27, 2002, applicant(s) hereby elects to prosecute Group I claims, claims 1-11 drawn to a method. As such, applicant(s) elects to withdraw Group II claims, claims 12-27 drawn to a composition.

If there are any additional charges, please charge Deposit Account No. 02-2666.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN

Date:

7/9/02

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